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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

REPLY TO OFFICE ACTION DATED 08/07/03

Atty. Docket No. **DUPONT1120-1**

Applicants

Michael J. Penberth, et al.

Application Number

Date Filed

09/262,778

03/04/99

Title

Electron Beam Blanking Method and System for Electron Beam Lithographic Processing

Group Art Unit

Examiner

2625

Chawan, Sheela C.

Confirmation Number:

9973

Certificate of Mailing Under 37 C.F.R. §1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22312-1450 on October 2, 2003.

Dear Sir:

P.O. Box 1450

Commissioner for Patents

Alexandria, VA 22313-1450

Printed Name

In response to the Official Action mailed August 7, 2003, Applicants respectfully request that the Examiner reconsider the rejections of the Claims in view of this reply.

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